Data analysis and Plotting

- Simulating STM images
- Bonding charge analysis
- Calculating surface energies

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STM microscopy

(Binning and Rohrer, 1986 Nobel prize for Physics)



Sample









STM microscopy

(Binning and Rohrer, 1986 Nobel prize for Physics)





1 nm

Sample

- Applied voltage between tip and sample results in electron tunneling
- Tunneling current exponential in the tip-sample distance
- •General expression for the tunneling current between sample and tip probe $2\pi e$

$$f = rac{2\pi e}{\hbar} \sum_{\mu
u} f(E_{\mu}) \left[1 - f(E_{\nu} + eV)\right] \times |M_{\mu
u}|^2 \delta(E_{\mu} - E_{\nu})$$
surface



$$M_{\mu\nu} \propto \psi_{\nu}(\mathbf{r}_0)$$

$$I \propto \sum_{\nu} |\psi_{\nu}(\mathbf{r}_0)|^2 \,\,\delta(E_{\nu} - E_F)$$

$$D(\mathbf{r}, E_F) = \sum_{\nu} |\psi_{\nu}(\mathbf{r})|^2 \,\delta(E_{\nu} - E_F)$$



I) The tip is assumed to be a point source
2) The tip electronic structure is assumed to be described by s wave function -->

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$$\int_{E_F}^{E_F+V} \sum_{\nu} |\psi_{\nu}(\mathbf{r})|^2 \,\delta(E_{\nu} - E) \mathrm{d}E$$



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$$D(\mathbf{r}, E_F) = \sum_{\nu} |\psi_{\nu}(\mathbf{r})|^2 \,\delta(E_{\nu} - E_F)$$

• In the limit of finite V and T=0 the current intensity is proportional to an integrated DOS:

$$\int_{E_F}^{E_F+V} \sum_{\nu} |\psi_{\nu}(\mathbf{r})|^2 \,\delta(E_{\nu} - E) \mathrm{d}E$$



Simulate the STM image of the AIAs (110) surface





I) Edit the file **run-alas**.**scf** and run the scf calculation of the AIAs(II0) surface.

2) Edit the file **run-alas**.**nscf**: Increase the number of k points and run the corresponding nscf calculation.

3) Set up the input file (run-alas.pp) for postprocessing the data (pp.x).

```
&inputpp
    prefix = 'AlAs110'
    outdir='$TMP_DIR',
    filplot = 'AlAs-1.0'
    sample_bias=XXX, <-- in Ry!
    plot_num= XXX
/
&plot_</pre>
```



4) Positive values of bias sample occupied states (positive tip with respect to sample), while negative values of bias sample empty states (negative tip with respect to sample).



5) Run the postprocessing calculation: run-alas.pp



```
6) Edit the file (run-alas.plot) for plotting the data (pp.x).
 &inputpp
 &plot
   nfile=xxxx
   filepp(1) = 'xxxx'
   weight(1) = xxx
   iflag=xx
   output format=xx
   fileout='AlAs110-1.0.xsf'
7) Run the calculation run-alas.plot
8) Visualize the simulated STM image with XCrysDen
```



Ex2: bonding charge density

<u>Calculate the bonding charge density of an O atom on the Al (001)</u> <u>surface</u>

- Inspect the following script run-Al-O-OAl-scf-pp It contains the procedure for calculating the charge densities of three separated systems:
 - a) an O atom adsorbed on an Al(001) slab,
 - b) an Al(001) slab,
 - c) an O atom.
- 2) Run the script
- 3) Visualize the crystal structures with XCrysDen

4)Compare the atomic coordinates of the O atom in the file **0.scf.out** with those in **OAL.scf.out**.



Ex2: bonding charge density

5) Set up an input file (**run-pp**) for the postprocessing program **pp.x**. The task is to subtract the charge densities of the Al(001) slab and of the O atom from the that one of the complete system O/Al(001)

```
&inputpp
nfile=xx
filepp(1)='???', weight(1)=???
filepp(2)='???', weight(2)=???
filepp(3)='???', weight(3)=???
iflag=xx
plot_out=xx
output_format=xx
fileout='OAl.chdensDIFF.xsf'
```



Ex2: bonding charge density

- 6) Run the script **run-pp**
- 7) Visualize the resulting bonding charge density with XCrysDen





Ex3: surface energy

The surface energy of single component systems can be defined as



 $\gamma = \frac{1}{2A} \left(E^S - E^B \right)$

•Error cancellation: Calculate E^S and E^B with the same computational parameters (basis set size, k-point mesh, smearing, ...)

•**Convergence:** Check convergence of with respect to computational parameters and supercell model: <u>k-point mesh</u> <u>cell thickness</u> <u>vacuum thickness</u>





Ex3: surface energy

Calculate the surface energy of the Cu(001) surface

$$\gamma = \frac{1}{2A} \left(E^S - E^B \right)$$

I) Model the Cu(001) surface with a tetragonal supercell slab having 4 atomic layers. Calculate E(slab).

2) Model the Cu bulk with a tetragonal supercell slab having 4 atomic layers. (Can you devise a more clever way of doing this calculation? Think at the k-point folding explored this morning ...) Calculate E(bulk)

3) Calculate the total surface area 2A (where A is the area of each supercell side).

4) Calculate the surface energy.



Ex3: surface energy

5) Increase the number of layers in the slab (keeping the same vacuum distance) and check the convergency of the surface energy.

6) Compare with the literature and experiment:

Surface	Method	$\gamma~({ m J/m^2})$	Δd_{12}	Δd_{23}	Δd_{34}	$d_0(hkl)$ (Å)	
Cu(111)	Theory a	1.30	-0.9	-0.3		2.10	
Cu(111)	Exp.	$\sim 1.79^{b}$	-0.7^{c}			inwards relax	cation
Cu(100)	Theory a	1.45	-2.6	1.5		1.821	
Cu(100)	Exp.	$\sim 1.79^{b}$	-2.1^{d}	0.4^d	0.1^d	1.807	
Cu(110)	Theory e	1.53	-10.8	5.3	0.1	1.29	
Cu(110)	Exp.	$\sim 1.79^b$	-8.5^{f}	2.3^{f}			